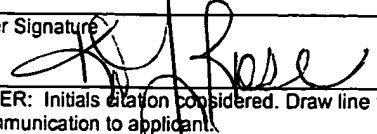


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| Substitute Form PTO-1449 (Modified) | U.S. Department of Commerce Patent and Trademark Office | Attorney's Docket No. 07977-024004 | Application No. |
| Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b)) | | Applicant Isamu Kobori et al. | |
| | | Filing Date | Group Art Unit |

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Other Documents (include Author, Title, Date, and Place of Publication)

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| Examiner Signature  | Date Considered 2/8/05 |
| EXAMINER: Initials may not be considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |

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| Substitute Form PTO-1449 (Modified) | U.S. Department of Commerce Patent and Trademark Office | Attorney's Docket No. 07977-024004 | Application No. |
| Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b)) | | Applicant Isamu Kobori et al. | |
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